



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Attorney Docket No. 2003_1364A

Takashi OHSAKO et al.

Confirmation No. 8585

Serial No. 10/677,221

Group Art Unit 2895

Filed October 3, 2003

Examiner Joannie A. Garcia

METHOD OF MANUFACTURING
SEMICONDUCTOR ELEMENT

Mail Stop: AMENDMENT

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated June 11, 2009, a Petition for a two month extension of time being submitted herewith, please amend the above-identified application as follows.